

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

First Named  
Inventor : David W. Duquet  
Appln. No. : 09/767,199  
Filed : January 22, 2001  
For : IMPROVED LASER ALIGN SENSOR  
WITH SEQUENCING LIGHT  
SOURCES  
Docket No.: C34.12-0021



Group Art Unit: 2877

Examiner:

01-17-02

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
Washington, D.C. 20231

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PATENT ATTORNEY

Sir:

The patents or publications listed on the enclosed PTO  
Form-1449 are submitted pursuant to 37 C.F.R. § 1.97. Copies of  
the patents or publications cited are enclosed.

The Director is authorized to charge any fee deficiency  
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Respectfully submitted,

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FORM PTO-1449		Atty. Docket No.: C34.12-0021	Appl. No.: 09/767,199
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT		First Named Inventor:	
		David W. Duquette	
		Filing Date	Group Art:
		January 22, 2001	2877

## U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Date	Name	Class	Sub Class	Filing Date If Appropriate
AA	4,974,010	11/27/90	Cleveland et al.	354	403	
AB	5,377,405	01/03/95	Sakurai et al.	29	833	
AC	5,491,888	02/20/96	Sakurai et al.	29	832	
AD	5,815,272	09/29/98	Harding	356	375	
AE	5,818,061	10/06/98	Stern et al.	250	559.29	
AF	5,897,611	04/27/99	Case et al.	702	150	
AG	6,028,671	02/22/00	Svetkoff et al.	356	368	
AH						
AI						
AJ						

## FOREIGN PATENT DOCUMENTS

	Document No.	Date	Country	Class	Sub Class	Translation Yes No
AK	8-111598	4/30/96	Japan			X (Abstract)
AL	9-214198	8/15/97	Japan			X
AM						
AN						

## OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

AQ	
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EXAMINER:

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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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